EXHIBIT K

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December 4, 1999

Ralph R. Veseli, Patent Attorney Maria Paula Kovacs, Paralegal Intellectual Property Mail Stop D-106 LSI Logic Corporation 1551 McCarthy Blvd. Milpitas, CA 95035 VIA FEDERAL EXPRESS

Re: Patent Application in Final Form for Execution Sheldon Aronowitz, Valeriy Sukharev, John Haywood, James P. Kimball, Helmut Puchner, Ravindra Manohar Kapre, and Nicholas Eib PROCESS FOR ETCHING A CONTROLLABLE THICKNESS OF OXIDE ON AN INTEGRATED CIRCUIT STRUCTURE ON A SEMICONDUCTOR SUBSTRATE USING NITROGEN PLASMA AND AN RF BIAS APPLIED TO THE SUBSTRATE LSI Docket No. 99-039

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Dear Ralph:

Enclosed are the followings documents for the above captioned LSI Logic patent docket which are to be used for the execution of the formal papers by the inventors:

- 1. Patent application on A4 paper;
- 2. One (1) sheet of formal drawings;
- 3. Declaration, Power of Attorney, and Petition to be signed by the inventors (in duplicate); and
- 4. Assignment to be signed by the inventors and witnessed (in duplicate).

Please note that per LSI's written instructions dated March 11, 1994, two copies (originals) of each of above items 3 and 4 are enclosed for execution, in duplicate, by the inventors. Naturally, the date on the Assignments should be the same as the date written on the Declarations.



Ralph R. Veseli, Patent Attorney Page Two

After the inventors have executed the Declarations and the Assignments, please return one executed original of each, together with the original application and the drawings, to my office so that they can be filed in the USPTO. I will then send you a copy of everything which is filed in the USPTO.

Regards,

John P. Taylor

Patent Attorney